

Notice of References Cited	Application/Control No. 09/990,965	Applicant(s)/Patent Under Reexamination LIU ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,072,615	06-2000	Mamyshev, Pavel V.	398/185
	B	US-6,081,355	06-2000	Sharma et al.	398/90
	C	US-6,097,525	08-2000	Ono et al.	398/185
	D	US-2003/0002121	01-2003	Miyamoto et al.	359/183
	E	US-6,819,872	11-2004	Farries et al.	398/102
	F	US-6,391,022	05-2002	Furumoto et al.	606/9
	G	US-6,587,239	07-2003	Hung, Henry	398/79
	H	US-2002/0021464	02-2002	Way, David G.	359/124
	I	US-6,496,297	12-2002	Frankel et al.	359/279
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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